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tel 415.318.1160 fax 415.693.0194

Applicant(s): Wayne G. Renken  
Title: Process Condition Sensing Wafer and Data Analysis System  
Application No.: 10/056,906 Filing Date: January 24, 2002  
Examiner: Charles D. Garber Group Art Unit: 2856  
Docket No.: SENS.005US0 Conf. No.: 2359

Mail Stop Amendment  
Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

Transmitted herewith are the following documents in the above-identified application:

- (1) Amendment (12 pages); and
- (2) Return Postcard.

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Franklin Dyer

Respectfully submitted,

*Peter A. Gallagher* 9/23/04  
Peter A. Gallagher Date  
Reg. No.47,584

34/34

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17-Jun-2005 11:22am From-PARSONS HSUE & DE RUNTZ LLP 4156930196 T-107 P.034/036 F-131	
<b>PARSONS HSUE &amp; DE RUNTZ LLP</b> 655 Montgomery Street, Suite 1600 San Francisco, Ca 94111 tel 415.318.1160 fax 415.693.0194	
Date	June 17, 2005
To	United States Patent and Trademark Office
Fax number	703-872-9305
Tel number	(800) 786-9199
From	Peter Gallagher, Reg. No. 47,594
Total pages	2
Subject	Status Request
Our Ref.	SENS.005US1
<b>COMMISSIONER FOR PATENTS</b> P.O. BOX 1480 ALEXANDRIA, VA 22313-1480	
Applicant:	Wayne G. Reuter
Title:	Process Condition Sensing Water and Data Analysis System
Application No.:	10/683,450
Filing Date:	October 14, 2003
Cont. No.:	4924
Any Docket No.:	SENS.005US1
ENCLOSURE:	
1. Request for Status - 1 page	
PAG/hop	
DUE DATE: n/a	
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PARSONS HSUE &amp; DE RUNTZ LLP

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**Date** June <sup>17</sup>/<sub>16</sub>, 2005  
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**Total pages** 2  
**Subject** Status Request  
**Our Ref.** SENS.005US1

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**COMMISSIONER FOR PATENTS**

**P.O. BOX 1450**  
**ALEXANDRIA, VA 22313-1450**

**Applicants:** Wayne G. Renken  
**Title:** Process Condition Sensing Wafer and Data Analysis System  
**Application No.:** 10/685,550  
**Filing Date:** October 14, 2003  
**Conf. No.:** 4924  
**Atty Docket No.:** SENS.005US1

**ENCLOSED:**

1. Request for Status - 1 page

PAG/aep

Due Date: n/a

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Wayne G. Renken  
Title: Process Condition Sensing Wafer and Data Analysis System  
Application No.: 10/685,550 Filing Date: October 14, 2002  
Examiner: Charles D. Garber Group Art Unit: 2856  
Docket No.: SENS.005US1 Conf. No.: 4924

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Ann-Ellice Parker  
Ann-Ellice Parker

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**REQUEST FOR STATUS OF APPLICATION**

Sir:

Applicant filed a Response to a Notice of Abandonment on February 16, 2005. Applicant hereby requests a report on the status of the above-identified patent application. If a telephone call would expedite this request, please call the Attorney of Record, shown below.

Respectfully submitted,

Peter A. Gallagher

Peter A. Gallagher  
Reg. No. 47,584

6/16/05  
Date

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